

**IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE**

Applicants: Geun Su Lee et al.) I hereby certify that this paper (along with
Serial No.: 10/723,029) any paper referred to as being attached or
Filed: November 26, 2003) enclosed) is being transmitted via EFS-
Title: Cleaning Solution for Photoresist) Web to the U.S. Patent and Trademark
and Method for Forming Pattern) Office on **December 27, 2006**.
Using the Same)
Group Art Unit: 1751)
Examiner: Gregory E. Webb)
Attorney Docket No.: 30205/39714)


Sandip H. Patel (Reg. No. 43,848)
Attorney for Applicants


Sabeen H. Patel (Reg. No. 42-848)

RESPONSE TO OFFICIAL ACTION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

This paper is presented in response to the non-final official action dated August 28, 2006.

A complete listing of the claims begins on page **2** of this paper.

Remarks begin on page 7 of this paper.